

2875

In re application of

Yuichiro MIYAMAE ET AL

Serial No. 10/537,156

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Filed: May 31, 2005

Title: Plasma display and method of producing phosphor used therein

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed herewith is a copy of the Official Filing Receipt for the above-identified application marked in red indicating corrections to be made thereto.

Accordingly, it is requested that the PTO issue a Corrected Filing Receipt reflecting these corrections.

Respectfully submitted,

YUICHIRO MIYAMAE ET AL

Ву

Filipek

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/eak

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513 WENDEROTH, LIND & PONACK, L.L.P. 2033 K STREET N. W. SUITE 800 **WASHINGTON, DC 20006-1021**

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CONFIRMATION NO. 1453 FILING RECEIPT *OC000000017648625*

WENDEROTH, LIND & PONACK

Date Mailed: 12/16/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

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Power of Attorney: The patent practitioners associated with Customer Number 513.

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Foreign Applications

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Non-Publication Request: No

NEXT PAGE

Early Publication Request: No

Title

Plasma display and method-for producing phosphor used therein

Preliminary Class

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